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Vibration reduction for smart periodic structures via periodic piezoelectric arrays with nonlinear interleaved-switched electronic networks

Bin Bao, Daniel Guyomar, Mickaël Lallart*

Univ. Lyon, INSA-LYON, LGEF, EA682, F-69621 Villeurbanne, France

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ABSTRACT

Smart periodic structures covered by periodically distributed piezoelectric patches have drawn more and more attention in recent years for wave propagation attenuation and corresponding structural vibration suppression. Since piezoelectric materials are special type of energy conversion materials that link mechanical characteristics with electrical characteristics, shunt circuits coupled with such materials play a key role in the wave propagation and/or vibration control performance in smart periodic structures. Conventional shunt circuit designs utilize resistive shunt (R -shunt) and resonant shunt (RL -shunt). More recently, semi-passive nonlinear approaches have also been developed for efficiently controlling the vibrations of such structures. In this paper, an innovative smart periodic beam structure with nonlinear interleaved-switched electric networks based on synchronized switching damping on inductor (SSDI) is proposed and investigated for vibration reduction and wave propagation attenuation. Different from locally resonant band gap mechanism forming narrow band gaps around the desired resonant frequencies, the proposed interleaved electrical networks can induce new broadly low-frequency stop bands and broaden primitive Bragg stop bands by virtue of unique interleaved electrical configurations and the SSDI technique which has the unique feature of realizing automatic impedance adaptation with a small inductance. Finite element modeling of a Timoshenko electromechanical beam structure is also presented for validating dispersion properties of the structure. Both theoretical and experimental results demonstrate that the proposed beam structure not only shows better vibration and wave propagation attenuation than the smart beam structure with independent switched networks, but also has technical simplicity of requiring only half of the number of switches than the independent switched network needs.

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1. Introduction

A periodic structure is composed of an assembly of identical elements connected in a repeating pattern. Examples of such structures can be found in many practical applications. Typically, they include rods [1,2], beams [3,4] or plates [5,6]. Due to their periodic nature, these structures may exhibit particular dynamic characteristics that make them acting as mechanical

* Corresponding author.

E-mail address: mickael.lallart@insa-lyon.fr (M. Lallart).<http://dx.doi.org/10.1016/j.ymssp.2016.05.021>

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Nomenclature			
L	inductance	Y_b	Young modulus of the substrate
C_0	capacitance of the PZT	ν_b	Poisson's ratio of the substrate
U	voltage on the PZT	S^E	mechanical compliance tensor of the piezo-electric material under constant electric field
U_{diff}	voltage difference between two PZTs	ϵ^T	electrical permittivity under constant stress
t_i	duration of the closed state of the switch connected to one PZT	d_{31}	piezoelectric charge constant
t_{id}	duration of the closed state of the switch connected between two PZTs	E_3	electric field intensity along x_3 direction
Q_e	electrical quality factor of the switch connected to one PZT	D_3	electrical displacement along x_3 direction
Q_d	electrical quality factor of the switch connected between two PZTs	σ	sign of the piezoelectric constant which depends on the polarization of the material
V_M	piezoelectric voltage of the PZT before the inversion process	T_{b1}	longitudinal stress of the substrate
V_m	piezoelectric voltage of the PZT after the inversion process	T_{p1}	longitudinal stress of the PZT
V_{Md}	voltage difference between two PZTs before the inversion process	S_1	strain along x_1 direction
V_{md}	voltage difference between two PZTs after the inversion process	t_p	thickness of the PZT
γ	inversion coefficient of the switch connected to one PZT	t_b	thickness of the pure beam
γ_d	inversion coefficient of the switch connected between two PZTs	$\phi(x)$	angle of rotation of the normal of the mid-surface of the beam
u	displacement of the structure	u_3	vertical deflection of the neutral axis in the x_3 direction
\dot{u}	velocity of the structure	x_c	neutral axis
M_k	dynamic mass	κ	Timoshenko shear coefficient
K_E	short-circuit stiffness	G	shear modulus
C_L	structural damping	E_b	elastic modulus of the substrate
α	force factor	E_p	elastic modulus of the PZT
F	external force	E_e	equivalent elastic modulus of the beam section with the PZT
$C_{equivalent}$	equivalent capacitance of two PZTs	$M_{bending}$	bending moment
ω	angular frequency	w_W	width of the bending beam
u_M	amplitude of the displacement of one PZT on the structure	I_b	second moment of area of the pure beam substrate's cross-section
u_{Md}	amplitude of the displacement difference between the displacement of one PZT and the displacement of the other PZT on the structure	I_p	second moment of area of the PZT's cross-section
$h(t)$	crenel function	I_e	equivalent second moment of area of the beam section with the PZT
$I(t)$	current flowing through the switch connected to one PZT	I_s	$=I_b$ referring to the substrate section or $=I_e$ referring to the beam section with the PZT
$I_{diff}(t)$	current flowing through the switch between two PZTs on the structure	U_s	strain energy
$g(\omega)$	$\sin(\omega t)$ in the frequency domain	T_k	kinetic energy
E_p^E	elastic moduli of the PZT in short circuit	W_e	work produced by the external transversal load
Z	electrical impedance of the shunting network	Q_s	shear force
k_{31}	electromechanical coupling coefficient	l	length of minimal finite beam element
N_g	number of interleaved unit cells	A_c	cross-sectional area of the substrate
N	number of primitive periodic cells	ρ	mass density of the material
γ_0	transverse shear strain constant	q, m	distributed forces and moments along the length l , respectively
		Q	electric charge on one PZT
		L_p	length of piezoelectric beam element
		n	number of finite beam elements
		$p_{1,2,3,4}$	signs of piezoelectric constant which depend on the direction of polarization of the piezoelectric patches 1,2,3,4 in the periodic cell

filters for traveling waves [7–10]. Specifically, waves can propagate over the surface of periodic structures within particular frequency bands called pass bands, and within other frequency regions called stop bands, propagative wave may be attenuated in amplitude and/or shifted in phase. The bandwidth and location of those pass bands/stop bands are influenced by properties such as periodic element length, stiffness, acoustic impedance ratio, Young's modulus ratio and thickness. When

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